

**Amendments to the Specification**

Please add the following new paragraph after the title of the application and before the first paragraph of the specification:

This application is a continuation of U.S. Patent Application No. 09/348,915, which was filed on July 7, 1999, and is entitled "Semiconductor Device with Alternating Conductivity Type Layer and Method of Manufacturing the Same," the disclosure of which is incorporated herein by reference.